



Docket No.: SON-2313  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Satoshi Ikeda

Application No.: 10/052,736

Confirmation No.: 3283

Filed: January 23, 2002

Art Unit: 2133

For: SEMICONDUCTOR TESTING APPARATUS  
AND METHOD

Examiner: J. C. Kerveros

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. SON-2313 from which the undersigned is authorized to draw.

Dated: April 6, 2006

Respectfully submitted,

By

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